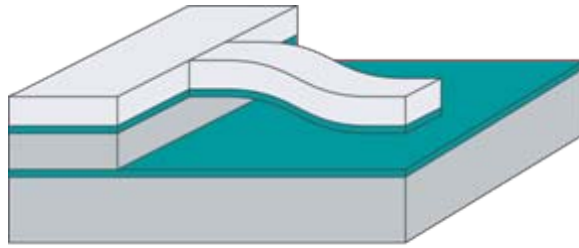


Surface Heterostructure Nanomechanical Actuators with Atomic Scale Resolution

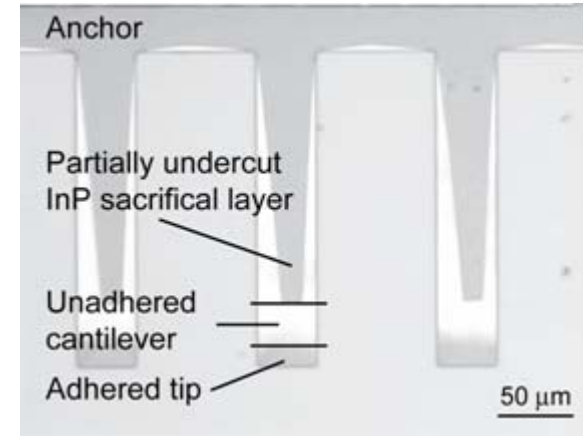
Joseph J. Talghader (PI), Jan D. Makowski

Electrical & Computer Engineering, University of Minnesota

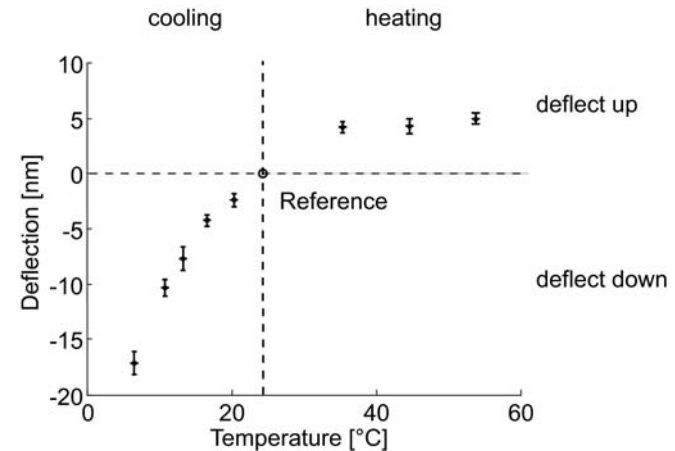
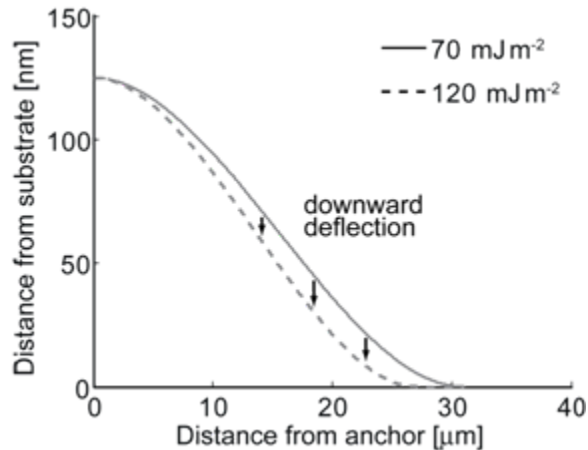


■ InP ■ InGaAs ■ SiN

Illustration of the heterostructure used in the project. Surface forces cause the cantilever to collapse over an 125 nm thick air gap.



A micrograph of the actual actuators



Maximum translation along the cantilever as a function of temperature

- Decrease in temperature increases the surface forces
- Length of unadhered part decreases
- Every Point on the cantilever undergoes vertical translation